



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 1775

Application No.: 10/690,021

Examiner: L. XU

Filed: October 22, 2003

Docket No.: 117581

For: FERROELECTRIC FILM, FERROELECTRIC CAPACITOR AND METHOD OF  
FABRICATING THE SAME, FERROELECTRIC MEMORY, PIEZOELECTRIC  
ELEMENT AND SEMICONDUCTOR

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the August 19, 2005 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**